

Notice of References Cited		Application/Control No.	Applicant(s)/Patent Under Reexamination YAMAMOTO ET AL.	
		Examiner Rip A. Lee	Art Unit 1796	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-4,207,373	06-1980	Segal, Leon	156/158
*	B	US-4,748,197	05-1988	Cordova et al.	524/114
*	C	US-6,058,994	05-2000	Amino et al.	152/167
*	D	US-3,328,339	06-1967	TIERNEY PAUL A	523/213
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	JP 11-106570	04-1999	Japan	Yamamoto et al.	C08L 23/00
*	O	WO 2004/39881 A1	05-2004	International	Yamamoto et al.	C09L 23/00
*	P	JP 2004-149635	05-2004	Japan	Yamamoto et al.	C08L 23/00
*	Q	EP 1 416 013 A1	05-2004	Europe	Yagi et al.	C08L 23/00
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	JP 11-106570 (04-1999) abstract and translation in English
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.

December 17, 2007